



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Application No.: 10/053,160

) Date: November 10, 2003

Applicant: Tsai-Yu Huang

) Examiner: Lan Vinh

) Group Art Unit 1765

Filed: 01/15/2002

) Our Ref: 619445-9 B-4453

For: "A Method of Etching A Mask
Layer ..."

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper responds to the Office Action dated August 8, 2003.
Please amend the above-identified application as described below. **All
remarks herein are made without prejudice.**

Amendments to the Claims are reflected in the listing of claims
which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.